

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	:	Attorney Docket No. 2006_0772A
Mitsuhiro OKUNE et al.	:	Confirmation No. 1821
Serial No. 10/581,256	:	Group Art Unit 1792
Filed May 31, 2006	:	Examiner Mahmoud Dahimene
PLASMA ETCHING METHOD	:	Mail Stop: AF

RESPONSE AFTER FINAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the final Office Action dated November 24, 2009, the Applicants herein request consideration of the following remarks.